

Application/Control No.	Applicant(s)/Patent und Reexamination	ier
10/024,179	ODA ET AL.	
Examiner	Art Unit	
Jean B. Corrielus	2637	

SEARCHED				
Class	Subclass	Date	Examiner	
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
East	8/8/2005	JBC
East	8/25/2005	JBC
East	8/26/2005	JBC